

UGCT: New X-ray radiography and tomography facility

B.C. Masschaele^{a,*}, V. Cnudde^b, M. Dierick^a, P. Jacobs^b,
L. Van Hoorebeke^a, J. Vlassenbroeck^a

^aDepartment of Subatomic and Radiation Physics, Ghent University, Proeftuinstraat 86, B-9000 Gent, Belgium

^bDepartment of Geology and Soil Science, Ghent University, Krijgslaan 281, B-9000 Gent, Belgium

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Abstract

The UGCT (University Gent Computer Tomography) facility, a cooperation between the Radiation Physics research group and the Sedimentary Geology and Engineering Geology research group is a new CT facility providing a large range of scanning possibilities. Formerly a Skyscan 1072 was used to perform X-ray micro-CT scans at the UGCT facility and although this is a very powerful instrument, there were needs for a higher resolution and more flexibility. Therefore, the UGCT facility started the construction of a multidisciplinary micro-CT scanner inside a shielded room with a maximum flexibility of the set-up. The X-ray tube of this high-resolution CT scanner is a state-of-the-art open-type device with dual head: one head for high power micro-CT and one for sub-micro- or also called nano-CT. An important advantage of this scanner is that different detectors can be used to optimize the scanning conditions of the objects under investigation. The entire set-up is built on a large optical table to obtain the highest possible stability. Due to the flexible set-up and the powerful CT reconstruction software “Octopus”, it is possible to obtain the highest quality and the best signal-to-noise of the reconstructed images for each type of sample.

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1. Introduction

Microtomography is a technique that allows scientists to investigate the structure of their samples with high spatial resolution without actually opening or cutting them. Without any form of sample preparation, it is possible to obtain a 3D computer model of the sample within 1–2 h of X-ray scanning and data reconstruction. The physical parameter which is providing the information about the structure is the X-ray linear attenuation coefficient μ . This coefficient is function of the electron density of the sample.

X-ray detectors are used to record the attenuation information along lines through the object. To detect the transmitted X-rays, they have to be converted to visible light with scintillation materials like GadoliniumOxysul-

phide (GdOS:Tb) or CsI crystals. The visible light from the scintillator is in turn registered by CCD camera's, CMOS-flat panels or amorphous Si-flat panels. Direct conversion detectors, like photon counting solid state arrays or amorphous Se, are still not used often but could be the future for microtomography.

Digital radiographs of the sample are made from different orientations by rotating the sample along the scan axis from 0° to 360° (full cone beam scan). Theoretically, the number of projections or radiographs necessary to reconstruct the internal structure of the object, is the product of the number of horizontal detector pixels and π [2].

2. Facility

The CT facility houses three different systems. The newest device is the high-resolution CT scanner. This is

*Corresponding author. Tel.: +329 2646532; fax: +329 2646697.

E-mail address: bert.masschaele@ugent.be (B.C. Masschaele).

why we will only briefly present the two other systems. More detailed information can be found on the website of the facility [3].

2.1. Micro-CT and nano-CT scanner

The main components of the new CT scanner are the X-ray tube, the sample manipulator and the X-ray detectors. Further, we have some extra components to facilitate the sample centering (Tables 1 and 2).

The X-ray tube is a state-of-the-art FXE-160.50 dual head open type source from Feinfocus. Open type means that one can open the tube to clean it or to replace filaments or targets. The dual head means that we have two tube heads, a high power directional head and a “nano” transmission head. The system has one high voltage unit and one vacuum system to evacuate the air. The X-ray source is mounted on a rotating platform. The reason is that the X-rays are emitted in the forward direction for the transmission tube and under 60° with respect of the tube axis for the directional head. When we change from one to tube to the other, we need to rotate the X-ray system by 60° .

2.1.1. X-ray imaging detectors

Since the ideal imaging detector does not exist, one should try to use different detectors to match the right detector to the right scanning conditions. For low-energy CT scans, we are using a Photonic Science VHR and a Rad-ikon CMOS RadEyeHR. For medium energy scans, we use a RadEye CMOS flat panel and for the high-energy scans, we use an image intensifier coupled to an optical CCD camera or a “scintillator/mirror/lens/

CCD” detector (also called camera box). The VARIAN Paxscan 2520 V with 14 bit dynamic range and CsI scintillator is used for the entire tube voltage range up to 160 kV.

2.1.2. Low energy

Biological samples and polymers are typically scanned at low kV settings to obtain high contrast projections. For these type of samples, we use a Photonic Science cooled CCD detector with a thin scintillator coupled to the sensor with an optical plate (taper ratio 1:1). The scintillator is 5 mg/cm^2 Gadolinium Oxysulphide. The sensor is $36 \text{ mm} \times 24 \text{ mm}$ and consists of 4008×2672 pixels of $9 \mu\text{m} \times 9 \mu\text{m}$. For distortion free images, we are using a RadEyeHR CMOS flat panel with 1600×1200 , $22 \mu\text{m}$ pixels.

2.1.3. Medium energy

Denser samples, like geological objects, are scanned with a remote Rad-eye EV detector from Rad-ikon. It is a CMOS sensor with 1024×512 pixels of $48 \mu\text{m} \times 48 \mu\text{m}$. The scintillator is a Lanex Fine with a thickness of 34 mg/cm^2 which is pressed onto a FOP (Fiber Optic Plate). The resolution is $48 \mu\text{m}$ (10 lp/mm). EV stands for extended voltage, which makes it possible to use the detector up to a tube voltage of 160 kV. The entrance window of the detector is 1 mm graphite. The dynamic range of the sensor is 4000:1, approximately 12 bit. The linearity is poor but correction methods do exist. Although the RadEye detector should allow us to work at 160 kV, it is not recommended. The dark current in the CMOS sensor increases quickly and damage has been observed. It is possible to replace the sensor in the case of radiation damage.

2.1.4. High energy

For the high-energy applications, we are using an image intensifier coupled to Sensicam PCO camera. The dual field image intensifier was bought from Precise Optics and has a circular field of view of $6''$ in low-resolution mode. The gain of the intensifier is fixed and it is important to optimize the ratio X-rays at the input to electrons in the CCD camera. We use an optical filter in front of the CCD lens to reduce the visible light intensity. The distortion inside the intensifier is considerable. For CT scanning, the distortion has to be corrected by a grid image and a calibration algorithm. The radiation damage is negligible at 160 kV. Copper beam hardening filters are placed in front of the detector to remove the low-energy X-rays. The pixel size is $136 \mu\text{m}$ in $6''$ mode or low-resolution mode.

A second detector is a camera box. Inside the box, the Sensicam CCD camera is observing the light from a scintillator. Since not all X-rays are stopped inside the scintillator we are using a surface coated mirror to deflect the light over 90° . The optical lens is a NIKKOR 50 mm f/1.4 MF lens.

Table 1
Properties for the directional head

Property Directional Head	Value
Voltage (kV)	20–160
Power (W)	Micro-focus: max. 10 High power: max. 320
Feature recognition (μm)	2 (defined by manufacturer)
Min. sample distance (mm)	4
Cone angle ($^\circ$)	40

Table 2
Properties for the transmission head

Property Transmission Head	Value
Voltage (kV)	20–160
Power (W)	Nano-focus: max. 1 Micro-focus: max. 3 High-power: max. 10
Feature recognition (μm)	0.3 (defined by manufacturer)
Min. sample distance (mm)	0.2
Cone angle ($^\circ$)	170

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